

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 89518
: Confirmation Number: 6138
Mou-Shiung Lin et al. :
Application No.: 09/523,990 : Group Art Unit: 2887
: Examiner: Daniel I. Walsh
: Filed: March 13, 2000
For: METHOD OF MANUFACTURE AND IDENTIFICATION OF SEMICONDUCTOR
CHIP MARKED FOR IDENTIFICATION WITH INTERNAL MARKING INDICIA
AND PROTECTION THEREOF BY NON-BLACK LAYER AND DEVICE
PRODUCED THEREBY

CHANGE TO LARGE ENTITY STATUS

Mail Stop Amendment
Commissioner for Patents
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I hereby certify that this correspondence is being electronically-transmitted to
the United States Patent and Trademark Office on April 9, 2010.
/Tobi A. Herbert/

Tobi A. Herbert

Sir:

This communication hereby notifies the United States Patent and Trademark Office of a change in status of the above-identified application from small entity to large entity. Any fees due in the above-identified application will be paid as large entity to reflect this change.

Respectfully submitted,
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